

6P 17162
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PATENT
Attorney Docket No.: AM524R1/T289

Assistant Commissioner for Patents,
Washington, D.C. 20231

on 2/12/99

By Sandy Kim

Sandy Kim

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent of:

MUSAKA et al.

Serial No.: 09/187,551

Date: November 5, 1998

For: METHOD OF FORMING A THIN
FILM FOR A SEMICONDUCTOR
DEVICE

Examiner: Unassigned

Art Unit: 1762

CHANGE OF CORRESPONDENCE
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Assistant Commissioner for Patents
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FEB 18 1999
GROUP 1700

Respectfully submitted,

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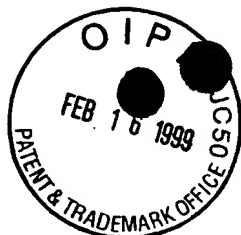
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTORNEY DOCKET NO.	DRWGS	TOT CL	IND CL
09/187,551	11/05/98	1762	\$1,168.00	AM524R1/T289	9	26	5

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Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Application Processing Division's Customer Correction Branch within 10 days of receipt. Please provide a copy of the Filing Receipt with the changes noted thereon.

Applicant(s)

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CONTINUING DATA AS CLAIMED BY APPLICANT-

THIS APPLN IS A RE OF 08/259,584 06/14/94 PAT 5,571,571
WHICH IS A CIP OF 08/184,331 01/19/94 ABN

FOREIGN APPLICATIONS- JAPAN 3-145070 06/16/93

TITLE

METHOD OF FORMING A THIN FILM FOR A SEMICONDUCTOR DEVICE

PRELIMINARY CLASS: 427

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DATA ENTRY BY: BATES, DIANE

TEAM: 03 DATE: 02/01/99

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